

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of

Nathan S. Lewis et al.

Application No.: 09/905,157

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Group Art Unit: 2813

Examiner: ERIK J KIELIN

Confirmation No.: 2732

Title: ELECTRICAL PASSIVATION OF SILICON-CONTAINING SURFACES USING ORGANIC LAYERS

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to: Respond to Office Action dated May 3, 2005

	one month to	September	3, 2005		\$120.00	×	\$60.00
☐ The shortened statutory period has been reset by an Advisory Action dated							
X	An extension	fee in the amo	unt of is enclosed.				
	Charge	to Deposit Account No. 02-4800.					
X	Charge	\$ 60.00	to credit ca	rd. Fo	m PTO-2038 i	s attach	ed.
The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.							
			Respectfully submitted,				
				В	JCHANAN INC	SERSOI	LL PC
Suite 300	o, CA 92130-20	090		Ву	Joseph R.J	Baker, J	<u></u>
Date:	September 2, 2	005			Registration	No. 4	0,900

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